Resistive switching characteristics of MnO$_x$-based ReRAM

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Abstract
The resistive switching characteristics of MnO$_x$ thin film were investigated for resistive random access memory (ReRAM) applications. The devices in the form of metal–insulator–metal structure exhibited reversible resistive switching behaviour under both sweeping voltages and voltage pulses. Formation and rupture of conductive filaments were proposed to explain the resistive switching. When Al was used as the top electrode instead of Pt, the device had a better endurance performance. Additionally, the Pt/MnO$_x$/Al device showed fast switching speed and long retention ability. The experiment result suggested that Pt/MnO$_x$/Al device had a potentiality for practical memory application.

(Some figures in this article are in colour only in the electronic version)

1. Introduction

Based on the resistive change of the insulator in a metal–insulator–metal (MIM) structure, resistance random access memory (ReRAM) possesses the advantages of low power consumption, high operation speed, nondestructive readout, simple structure and good scalability, which is a highly competitive candidate for the generation of nonvolatile memories. A variety of materials have been studied for ReRAM application including ferromagnetic material such as Pr$_{1-x}$Ca$_x$MnO$_3$ [1], doped perovskite oxides such as SrZrO$_3$ [2], organic materials [3] and doped and undoped transition metal oxides (TMOs) [4–11]. Among these materials, TMOs are extensively studied due to their simple structure, easy fabrication process and excellent compatibility with current complementary metal oxide semiconductor (CMOS) technology [4]. Many TMOs have been reported to exhibit resistive switching phenomena, such as NiO [5], ZnO [6], Cu$_2$O [7], ZrO$_2$ [8, 9], TiO$_2$ [10] and Nb$_2$O$_5$ [11]. It is thought that resistive switching is an intrinsic property of TMOs, and all doped and undoped TMOs can exhibit resistive switching [12]. However this hypothesis needs to be confirmed since many other TMOs have not been studied.

In this paper, we investigate the resistive switching behaviour of manganese oxides, which have rarely been reported before. The manganese oxide film was deposited by electron beam evaporation and sandwiched between two metal electrodes in the forms of Pt/MnO$_x$/Pt and Pt/MnO$_x$/Al. These devices exhibited stable resistive switching behaviour under dc sweeping voltages. It was noticed that Pt/MnO$_x$/Al device had a better endurance performance than Pt/MnO$_x$/Pt, which could be due to aluminium depriving oxygen from the MnO$_x$ thin film. The study of MnO$_x$ may help to achieve a better understanding of resistive switching characteristics of TMOs.

2. Experimental details

The MnO$_x$-based memory devices were fabricated as follows: (1 0 0)-oriented silicon wafers were chemically cleaned, and then a 150 nm thick SiO$_2$ film was thermally grown. A Ti layer and Pt film (with thicknesses of 10 nm and 50 nm, respectively) were deposited sequentially onto the substrates by electron beam evaporation. Ti was used as an adhesive layer and Pt served as the bottom electrodes (BEs). After that, a 150 nm thick MnO$_x$ thin film was e-beam evaporated onto the Pt film using a MnO$_2$ target in an ambient pressure of 2.6 × 10$^{-6}$ Torr at room temperature (RT). Finally...
In a vacuum condition. In the evaporation, MnO₂ would decompose so that the manganese element was at different chemical states. The film was deposited by e-beam evaporation using MnO₂ target in a metal matrix. Those defects were thought to play important roles in resistance hysteresis [5, 8–10].

X-ray photoelectron spectroscopy (XPS) analysis was utilized to investigate the chemical states of the MnOₓ matrix. The current–voltage characteristics of the fabricated devices were measured by a Keithley 4200-SCS semiconductor characterization system. The pulse test was performed with an Agilent 81110A Pulse Pattern Generator and a Tektronix DPO7104 digital phosphor oscilloscope.

Figure 1. XPS spectra of Mn 2p\textsubscript{3/2} of the as-deposited MnOₓ film. The film was deposited by e-beam evaporation using MnO₂ target in a metal matrix. The author of [13] took a small calibration made to the data. In XPS analysis C 1s was used as a standard for the correction of charging effects. The authors of [13] took the energy of C 1s as 284.8 eV, so there was a shift of 0.2 eV. So there was a shift of 0.2 eV.

Figure 2 shows the typical J–V curves of both Pt/MnOₓ/Pt and Pt/MnOₓ/Al devices. The inset of figure 2 is the schematic configuration of the measurement. Sweeping voltages were applied to the TEs of the sandwich devices while Pt BEs were grounded. The pristine devices were in the high resistance state (HRS). When the voltage went from zero to a high voltage, an abrupt current increase occurred at about 8 V, indicating the devices changed to a low resistance state (LRS). That soft breakdown is the so-called ‘set’ process, corresponding to the ‘writing 1’ process of memories. The current flowing through the devices was limited to a maximum value by the test equipment to protect the devices from perpetual breakdown. After set on, a sweeping voltage without current compliance was applied again, and a dramatic current drop appeared, indicating that the devices changed back to the HRS, which is the so-called ‘reset’ process. The switching between high and low resistance could be done repeatedly. Set and reset operations could be achieved under positive and negative voltages, and they could be done in succession changing or unchanging voltage polarity. That is, the resistance switching did not depend on the polarity of the applied voltage and it was defined as nonpolar resistive switching characteristic [15]. Resistance switching under voltage pulses was also feasible. Set operation could be induced by a 100 ns pulse of 12 V and reset by a 200 ns pulse of 2 V.

Several hypothetical models have been proposed to explain resistive switching phenomena, such as formation and rupture of conductive filaments [10], trap charging and discharging [9] and modulation of Schottky barrier height [16, 17]. But until now, the underlying mechanism is still controversial. On the basis of the measured electrical characteristics, the filamentary mechanism is appropriate to explain our devices resistance switching. According to the filamentary mechanism, when the electric field is high enough, defects such as oxygen vacancies or metallic ions align to form conductive filaments which connect the two electrodes. After the conductive filaments are formed, the current flows mainly
through the filaments and the devices turn to low resistance and exhibit Ohmic behaviour, which is consistent with the unity slope of the double-logarithmic-plotted LRS $I$–$V$ curves in figure 2. During the reset process, these conductive filaments break as a result of the Joule heating generated by large current, which makes the devices turn back to the HRS.

It was found that the endurance property of Pt/MnO$_x$/Al was much better than that of the Pt/MnO$_x$/Pt device. Most of the Pt/MnO$_x$/Pt devices broke down after a few set/reset cycles, and then acted as stable low value resistors, while several Pt/MnO$_x$/Al devices could still function after more than 100 dc switching cycles under the condition that the devices were set by negative sweeping voltages. It is proposed that more oxygen vacancies caused by aluminium depriving oxygen from the MnO$_x$ layer are the reason for the endurance difference. Aluminium is known to be able to get oxygen from TMOs to form oxides [18]. According to the filamentary mechanism, during the set process, conductive filaments propagate from the cathode and filaments at the anode side are weaker (or less conductive) than the ones near the cathode. The filaments rupture in a localized region near the anode during the reset process and recover in the subsequent set process [10]. The rest of the filaments are preserved during the whole switching process. As to our situation, the filaments broke and recovered in the MnO$_x$ layer. This layer had been deprived of oxygen by the aluminium electrode and possessed more oxygen vacancies, making conductive filaments’ formation or recovery easier, so the Pt/MnO$_x$/Al devices exhibited an improved endurance property.

Figure 3(a) depicts the dependences of high and low resistance of the Pt/MnO$_x$/Al devices on the size of the TEs.

With the increase in the size of the TEs, the resistances of the HRS of the Pt/MnO$_x$/Al device got smaller, while the values of the LRS showed no dependence on the device sizes, which was in agreement with the localized conductive filament mechanism. As shown in figure 3(b), $V_{set}$ (defined as the threshold voltage where set switching occurred) had little reliance on the cell area, while $I_{set}$ (defined as the current when the set occurred) increased with larger cell size. This indicates that the electrical field required to form conductive filaments is constant and the conduction of the HRS is almost homogeneous. Those properties suggest that Pt/MnO$_x$/Al devices have considerable advantages in regard to scalability.

Shown in figure 4 is the dependence of the resistance on the repetitive switching cycles of a $200 \times 200 \mu m^2$ Pt/MnO$_x$/Al device. The device was set by negative voltage and reset by positive voltage. Resistance values were obtained at 0.3 V. As can be seen from the experimental data, the low resistance values were distributed in a narrow range around 100 $\Omega$, while the high resistance values were around 1 M$\Omega$. The narrow dispersion of resistance values guarantees a sensing margin larger than three orders. Uniformity of memory parameters such as resistance values is very important for practical application. Compared with some other TMO based devices [6, 7, 11], the Pt/MnO$_x$/Al memory devices exhibited better uniformity of resistances. The inset of figure 4 depicts the distribution of the threshold voltages for set and reset ($V_{set}$ and $V_{reset}$). There is no overlap between $V_{set}$ and $V_{reset}$, which ensures the MnO$_x$-based device can be well operated in the application of ReRAM. To further confirm the potentiality of practice memory application, the state retention property of Pt/MnO$_x$/Al was checked at RT and 85 $^\circ$C, respectively. Figure 5 shows the time-dependent resistance evolution. The test at RT was done for over $10^5$ s and retention at 85 $^\circ$C was over $10^4$ s. In both situations, the resistances of LRS exhibited little change, while those of HRS became larger, resulting
in larger HRS/LRS ratios, and enhanced the memory’s reliability.

4. Conclusions

In summary, the resistive switching characteristics of MnO$_x$-based ReRAM were investigated for nonvolatile resistance memory applications. It was found that devices of both Pt/MnO$_x$/Pt and Pt/MnO$_x$/Al exhibited the reversible nonpolar resistance switching phenomenon. The switching between HRS and the LRS could be achieved under dc sweeping voltage as well as pulse voltages. According to the electrical characteristics, we proposed that the resistance switching was caused by the formation and rupture of conductive filaments. The Pt/MnO$_x$/Al devices exhibited better endurance performance than the Pt/MnO$_x$/Pt devices. The resistance evolution with cycles and the nonvolatile property of the Pt/MnO$_x$/Al structure were also demonstrated. The ratio of high resistance to low resistance was over three orders of magnitude and the resistance values of both states showed narrow dispersions in 100 cycles. Time-dependent tests showed the devices had good retention properties. All the experimental data suggested that the Pt/MnO$_x$/Al device had the potential for future memory application.

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